

CS-01-132



December 12, 2003

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/664,211 09/17/03 |

Purakh Raj Verma et al.

A METHOD OF MAKING DIRECT CONTACT
ON GATE BY USING DIELECTRIC STOP
LAYER

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

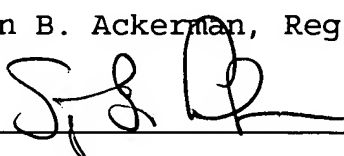
The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56. Copies of each document is included herewith.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first class
mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on December 19, 2003.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

 12/19/03

CS-01-132

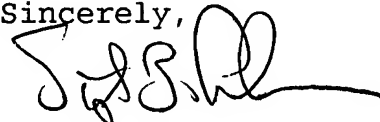
U.S. Patent 5,731,239 to Wong et al., "Method of Making Self-Aligned Silicide Narrow Gate Electrodes for Field Effect Transistors Having Low Sheet Resistance," describes a method for making low sheet resistance sub quarter micrometer gate electrode in FET devices.

U.S. Patent 6,010,954 to Ho et al., "CMOS Gate Architecture for Integration of Salicide Process in Sub 0.1uM Devices," describes a method to form a "mushroom shaped" gate structure that increases the top gate silicide contact area and improves the salicidation process.

U.S. Patent 6,271,087 to Kinoshita et al., "Method for Forming Self-Aligned Contacts and Local Interconnects Using Self-Aligned Local Interconnects," describes a method for forming self-aligned contacts and local interconnects.

U.S. Patent 6,281,059 to Cheng et al., "Method of Doing ESD Protective Device Ion Implant Without Additional Photo Mask," describes a method of forming ESD protective transistor.

Sincerely,

A handwritten signature in black ink, appearing to read 'S. B. Ackerman', with a long horizontal flourish extending to the right.

Stephen B. Ackerman,
Reg. No. 37761

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.